



**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800**

Attorney Docket No. 051876.P352

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:

Byung-Seop Hong

Serial No. 10/648,183

Filed: August 25, 2003

**METHOD FOR RELEASING STRESS DURING
SEMICONDUCTOR DEVICE FABRICATION**

Examiner: Trung Q. Dang

Art Unit: 2823

*O.K To Enter
T.D. Am
4/3/06*

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Sir:

In response to the Final Office Action mailed January 10, 2006, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.